

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1-2. (Canceled).

3. (Previously Presented) The nanoprint mold according to claim 5, wherein portions periphery portion of said laminated structure on the side where the concave-convex pattern is formed are inclined such that the center portion of said laminated structure has a larger thickness than an edge portion of said laminated structure.

4. (Previously Presented) The nanoprint mold according to claim 5, wherein the periphery portions of said laminated structure on the side on which the concave-convex pattern is formed are inclined such that the center portion of said laminated structure has a smaller thickness than an edge portion of said laminated structure

5. (Currently Amended) A nanoprint mold for deforming a flat resin substrate or a flat resin film on a substrate to form a fine structure on a substrate with the use of a press machine, said mold comprising a laminated structure, said laminated structure including a base member having flat surface and a curved surface on a side of the base member opposite the flat surface, and a pattern member having a concave-convex pattern, said pattern member being bonded to the curved surface of said base member, perimeters of said pattern member and said base member being coextensive, said mold being provided with a curved surface on the side thereof on which the concave-convex

pattern is formed, and the side of said mold on which the concave-convex pattern is formed is provided with a deep groove, deeper than concave portions of the concave-convex pattern, at a center portion of the mold between periphery portions, wherein the flat resin substrate or the flat resin film on the substrate is inflected and pressed using the press machine and the nanoprint mold, and the deep groove extends and is open to the periphery portions to allow air to be introduced into the deep groove and provide a release start point for releasing the mold from the flat resin substrate or flat resin film during use of the mold.

6. (Previously Presented) The nanoprint mold according to claim 5, wherein said press machine comprises a heating and pressing mechanism.

7. (Canceled)

8. (Previously Presented) The nanoprint mold according to claim 5, wherein said mold is flexible.

9-24. (Canceled)

25. (Previously Presented) The nanoprint mold according to claim 5, wherein a second deep groove, deeper than concave portions of the concave-convex pattern and crossing the deep groove, is provided on the side of the mold on which the concave-convex pattern is formed at a center portion and extending and opening to periphery portions.

26. (Previously Presented) The nanoprint mold according to claim 5, wherein the concave or convex portions of the concave-convex pattern have a width or diameter of 300 nm or less.

27. (Previously Presented) The nanoprint mold according to claim 5, wherein the base member having the curved surface is bonded to the pattern member having the concave-convex pattern with an adhesive.

28. (Previously Presented) The nanoprint mold according to claim 27, wherein the adhesive is a silicone adhesive.